Electronic Pat	ent App	lication Fe	Transm	ittal			
Application Number:	107	10721075					
Filing Date:	26-	26-Nov-2003					
Title of invention:		LASER IBRADIATION APPARATUS, LASER IBRADIATION METHOD, AND METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE					
First Named Inventor/Applicant Name:	Koi	Koichiro Tanaka					
Filer:	Eric	Eric J. Robinson/Doris Vasquez Soriano					
Attorney Docket Number:	075	0756-7223					
Filed as Large Entity	•						
Utility under 35 USC 111(a) Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Utility Appl issue fee		1501	1	1510	1510		

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	3	3	9
	Total in USD (\$)			1819